Express Mail No. EU627418596US Attorney Docket No.: AM-5256-2.Y1

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Jeng H. Hwang et al.

SUBSEQUENT HIGH TEMPERATURE ETCHING

§ GROUP ART UNIT: 1765

SERIAL NO.: 09/747,667

EXAMINER: S. Ahmed

FILED: December 22, 2000

PLASMA HEATING OF A SUBSTRATE WITH § Attorney Docket No.:

AM-5256-2.Y1

Date: August 22, 2003

## SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT **UNDER 37 CFR § 1.97(b)(1)**

Hon. Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

FOR:

In a ccordance with 3 7 CFR § 1.97(b)(1), applicants hereby request consideration of this Supplemental Information Disclosure Statement. This Supplemental Information Disclosure Statement is being submitted with the filing of a Request for Continued Examination (RCE) in the subject application. Because this Supplemental Information Disclosure Statement is being submitted simultaneously with (within three (3) months of) the filing of the RCE, applicants do not believe that any fee is due in connection with the filing of this Supplemental Information Disclosure Statement.

## **CERTIFICATE OF MAILING UNDER 37 CFR 1.10**

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. EU627418596US in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: August 22, 2003

Shirley L. Church, Reg. No. 31,858

Applicants are providing herewith a copy of each document cited on the attached Form

PTO-1449.

The submission of this Supplemental Information Disclosure Statement and Form PTO-1449

is not an admission that the art cited is "prior art" with respect to the present invention, nor is it a

representation that no better art exists. Applicants hereby reserve the right to swear behind or

otherwise disprove any alleged "prior" nature of any art cited should the facts support and the

situation warrant such an action.

If the Examiner has any questions, he is respectfully requested to contact the undersigned

attorney at the telephone number set forth below.

Respectfully submitted,

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FORM PTO-1449 (Equivalent)

U.S. Department of Commerce Patent and Trademark Office

U.S. Application Serial No. 09/747,667

Atty. Docket No. AM-5256-2.Y1

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use several sheets if necessary)

Jeng H. Hwang et al. Applicants

December 22, 2000 Filing Date

1765 Group

U. S. PATENT DOCUMENTS

Examiner <u>Initial</u>	Document Number	Issue <u>Date</u>	Name	Class	Subclass	Filing Date  If Appropriate
	6,261,967	07/17/01	Athavale et al.	438	717	02/09/00
<del></del>	6,547,978	04/15/03	Ye et al.	216	75	08/07/98

U. S. PATENT APPLICATION DOCUMENTS

Examiner Initial	Document Number	Publication Date	Name	Class	Subclass	Filing Date If Appropriate
	2001/0053610A1	12/20/01	Athavale et al.	438	710	09/14/99

Examiner

Date Considered

Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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